

Politechnika Świętokrzyska

# WYDZIAŁ ELEKTROTECHNIKI, AUTOMATYKI I INFORMATYKI

Załącznik nr 9 do Zarządzenia Rektora PŚk Nr 35/19 w brzmieniu ustalonym Zarządzeniem Nr 12/22

## **COURSE DESCRIPTION**

Course code	full-time studies				
	part-time-studies				
Course name	Ochrona własności intelektualnej				
Course name in English	Protection of intellectual property				
Valid from academic year	2022/23				

#### PLACEMENT IN THE TEACHING PROGRAM

Field of study	Computer Science
Level of education	1 <sup>st</sup> degree
Studies profile	General
Form and method of teaching classes	Full-time and part-time studies
Specialization	All specializations / Information systems / Computer graphics / Information and communica- tion technology
Organizational unit responsible for the course	Department of Quality and Intellectual Property Management
Course coordinator	PhD Magdalena Kotulska-Kmiecik
Approved by	Dean of the Faculty of Electrical Engineering, Automatic Control and Computer Science Roman Deniziak, KUT prof., DSc, PhD

## GENERAL CHARACTERISTIC OF THE COURSE

Course affiliation		subjet of general education				
Course status		obligatory				
Language		polish				
0	full-time studies	I semester				
Semester	part-time-studies	I semester				
Requirements		No				
Exam (YES/NO)		No				
ECTS		1				

Course form		lecture	classes	laboratory	project	other
Hours per	full-time studies	15				
semester	part-time-studies	9				

## LEARNING RESULTS

Category	Result Symbol	Learning Results	References to the field of study results		
	W01	The student has knowledge about the sources, structure, functions and institutions of intellectual property law. Can define and interpret legal norms in the field of intellectual property legislation.	INF1_W01		
Knowledge	W02	The student knows the principles of copyright protection and protection of industrial property, in particular the pro- tection of patent. Understands the importance of this area of law for the development of technology and mo- dern economy.	INF1_W01		
Skills	U01	The student demonstrates the ability to apply provisions of the Act on Copyright and Related Rights and Indu- strial Property Law in typical cases actual situations.	INF1_U01		
SKIIS	U02	The student is able to use responsibly protected works and databases. Is able to apply for protection for indivi- dual items of industrial property.	NF1_U01		
Social	K01	The student uses protected works in accordance with the law. Applies the principles of respecting copy- rights when implementing creative works, including design and diploma works.	INF1_K06		
competence	K02	The student is able to cooperate and work in a group and act ethically within designated organizational and social roles.	INF1_K07		

## **COURSE CONTENT**

Course	Contont
Form	Content

lecture	<ul> <li>1. The concept of intellectual property law and its place in the legal system</li> <li>Internal structure</li> <li>Sources of intellectual property law</li> <li>Types of intellectual property</li> <li>Protection models</li> <li>Economic system and technical progress</li> <li>Functions of intellectual property law</li> <li>2. Copyright</li> <li>Work as a subject of copyright</li> <li>Exclusions from protection</li> <li>Copyright protection</li> <li>Copyright protection</li> <li>Types, content and scope of copyright</li> <li>Fair use of protected works</li> <li>Legal liability for copyright infringement</li> <li>Protection of IT products and other solutions used in online activities</li> <li>Database protection</li> <li>Case studies</li> <li>Legal liability of university students for committing crime of plagiarism</li> <li>Case studies</li> <li>Patent Office of the Republic of Poland – tasks, structure</li> <li>The concept of the Republic of poland – tasks, structure</li> <li>The concept of the registering an invention and utility model in Poland</li> </ul>
	<ul> <li>Case studies</li> <li>Legal liability of university students for committing crime of plagiarism</li> </ul>
	<ul> <li>Patent Office of the Republic of Poland – tasks, structure</li> </ul>
	Conditions for patentability and protection
	6. Patent law and utility model law
	Content of the patent and the content of the utility model protection right
	<ul> <li>Fair use under patent law</li> <li>Legal liability for infringement of industrial property rights</li> </ul>
	The role of a patent attorney in proceedings before the Polish Patent Office

#### LEARNING RESULTS VERIFICATION METHODS

Result Symbol	Learning results verification methods									
	Oral Exam	Written Exam	Midterm	Project	Report	Other				
W01			Х	Х		Х				
W02			Х	Х		Х				
U01			Х	Х		Х				
U02				Х		Х				
K01			Х	Х		Х				
K02				Х		Х				

#### ASSESSMENT FORMS AND CRITERIA

Course Form	Assessment Form	Assessment Criteria
lecture	pass with grade	Obtaining at least 50% points on the test; preparing and pre- senting a multimedia presentation, solving a specific legal problem (case)

#### STUDENT'S VOLUME OF WORK

	ECTS Balance											
No.	Activity Type	Student Involvement									Unit	
NO.		f	ull-ti	me st	udie	5	part-time-studies					
1.	Participation in classes according		С	Lab	Ρ	S	Lec	С	Lab	Ρ	S	h
••	to the schedule	<mark>15</mark>					9					
2.	Other (consultations, exams)	<mark>2</mark>					2					h
3.	Total with the direct assist of an academic teacher			17					11			h
4.	Number of ECTS, that students obtains with the direct assist of an academic teacher	0,68					0,44				ECTS	
5.	Hours of unassisted student work	8					14				h	
6.	Number of ECTS that student obtains working unassisted			0,32			0,56				ECTS	
7.	Practical classes volume of work		0						0			h
8.	Number of ECTS obtained by student at practical classes	0,0					0,0					ECTS
9.	Total student's volume of work expressed in hours	25					25				h	
10.	ECTS						1					ECTS

#### BIBLIOGRAPHY

- 1. Adamczak A, du Vall M., (red.), Ochrona własności intelektualnej, UOTT UW, Warszawa 2010.
- 2. Sieńczyło-Chlabicz J. (red.), *Prawo własności intelektualnej. Teoria i praktyka*, Wolters Kluwer Polska, Warszawa 2021
- 3. Ustawa o zwalczaniu nieuczciwej konkurencji z 16.04.1993 r. (t.j. Dz. U. z 2022 r. poz. 1233)
- 4. Ustawa o prawie autorskim i prawach pokrewnych z 4.02.1994 r. (t.j. Dz. U. z 2022 r. poz. 2509)
- 5. Ustawa prawo własności przemysłowej z 30.06.2000 r. (t.j. Dz. U. z 2023 r. poz. 1170).